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CONFIRMATION NO. 4436

Bib Data Sheet

SERIAL NUMBER 10/524,064	FILING OR 371(c) DATE 02/08/2005 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. 052107	
APPLICANTS Kouji Haga, Hitachi-shi, JAPAN; Yuto Ootsuki, Hitachi-shi, JAPAN; Yasushi Kurata, Hitachi-shi, JAPAN; Kazuhiro Enomoto, Mito-shi, JAPAN; <i>verify LTM-E</i>					
** CONTINUING DATA ***** This application is a 371 of PCT/JP03/10001 08/06/2003					
** FOREIGN APPLICATIONS ***** <i>verify LTM-E</i> JAPAN 2002-233702 08/09/2002 JAPAN 2003-59280 03/06/2003					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance		STATE OR COUNTRY JAPAN	SHEETS DRAWING	TOTAL CLAIMS 7	INDEPENDENT CLAIMS 2
Verified and Acknowledged Examiner's Signature _____ Initials _____					
ADDRESS 38834					
TITLE Polishing slurry for chemical mechanical polishing and method for polishing substrate					
FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		